



PATENT

ATTORNEY DOCKET NO: 203.45
(AMAT DOCKET NO. 00301USAC01)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

V. Sivaramakrishnan et al.

Serial No. 09/919,633

Filed: July 31, 2001

For: **VAPORIZING REACTANT
LIQUIDS FOR CHEMICAL
VAPOR DEPOSITION FILM
PROCESSING**

) Group Art Unit: 1763

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) Examiner: Bueker, R.

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) **PETITION FOR THREE-MONTH
EXTENSION OF TIME**

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CERTIFICATE OF MAILING

I hereby certify that the correspondence enclosed herein is being deposited as first class mail with the United States Postal Service on this date, June 13, 2003, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

By: 

Saundra D. Hunter

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby petition for a three-month Extension of Time to answer the outstanding Office Action dated March 11, 2003, regarding the above-referenced patent application. Please find enclosed a check in the amount of \$930.00 for the extension fee.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment to Deposit Account No. 04-0822. A duplicate copy of this sheet is submitted.

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Respectfully submitted,

DERGOSITS & NOAH LLP

Dated: June 13, 2003By: 

Samuel S. Lee

Registration No. 41,938

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